

8-20-01
Docket: 740756-2332



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Patent Application of)
Takeshi FUKADA et al.)
Based On Serial No. 09/294,338) Art Unit: 2825
Which Was Filed: April 20, 1999) Examiner: L. Malsawma
For: GLASS SUBSTRATE ASSEMBLY,))
SEMICONDUCTOR DEVICE AND))
METHOD OF HEAT-TREATING))
GLASS SUBSTRATE) Date: July 16, 2001

INFORMATION DISCLOSURE STATEMENT


Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 09/294,338 filed April 20, 1999, and the predecessor applications including Serial Nos. 08/462,773 and 08/311,275.

Respectfully submitted,


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